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Appl. No. 09/451,619

Amdt. Dated November 2, 2004

Reply to final Office Action of July 2, 2004

Attorney Docket No. 81788.0025

Customer No.: 26021



**AFTER FINAL RESPONSE UNDER 37 C.F.R. §1.116
EXPEDITED PROCEDURE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Seiichi Mori

Serial No: 09/451,619

Confirmation No.: 9292

Filed: November 30, 1999

For: **NON-VOLATILE SEMICONDUCTOR
MEMORY AND MANUFACTURING
METHOD THEREOF**

Art Unit: 2814

Examiner: Howard Weiss

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

November 2, 2004

Date of Deposit

William H. Wright, Reg. No. 36,312

Name

Signature

Date

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This is in response to the final Office Action dated July 2, 2004. The time for response to the outstanding final Office Action is extended one month by the accompanying petition from October 2, 2004 to November 2, 2004. Please amend the above-referenced application as follows:

Amendments to the claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.